



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Handwritten: 0.681764
#61B
11.29.00

In re the application of

EIPEL et al.

Serial No.: 09/241,868

Filed: January 14, 1999

For: SOLID SUPPORTS FOR ANALYTICAL MEASUREMENT METHODS, AND THEIR PRODUCTION AND THEIR USE

Group No. 1743

Examiner: L. Alexander

RECEIVED
NOV 28 2000
TC 1700 MAIL ROOM

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner of Patents and Trademarks, Washington, D.C. 20231, on:

Date of Deposit

Person Making Deposit

Signature

Date of Signature

Honorable Commissioner of
Patents and Trademarks
Washington, D.C. 20231

AMENDMENT

Sir:

In response to the office action of August 18, 2000, kindly amend the above-identified application as follows.

IN THE CLAIMS

Please amend claims 1 and 8 as follows.

1.(amended) A solid support for analytical measurement methods which is essentially composed of an inert solid support material on which hydrophilic measurement zones [which may be provided with a surface loading] are separated from one another by at least one non-continuous hydrophobic coating, where the number of measurement points applied per cm² of the support is greater than or equal to 10.